



# Computational Modeling of Metal Oxidation

**Youhai Wen** and Tianle Cheng

US Department of Energy - NETL

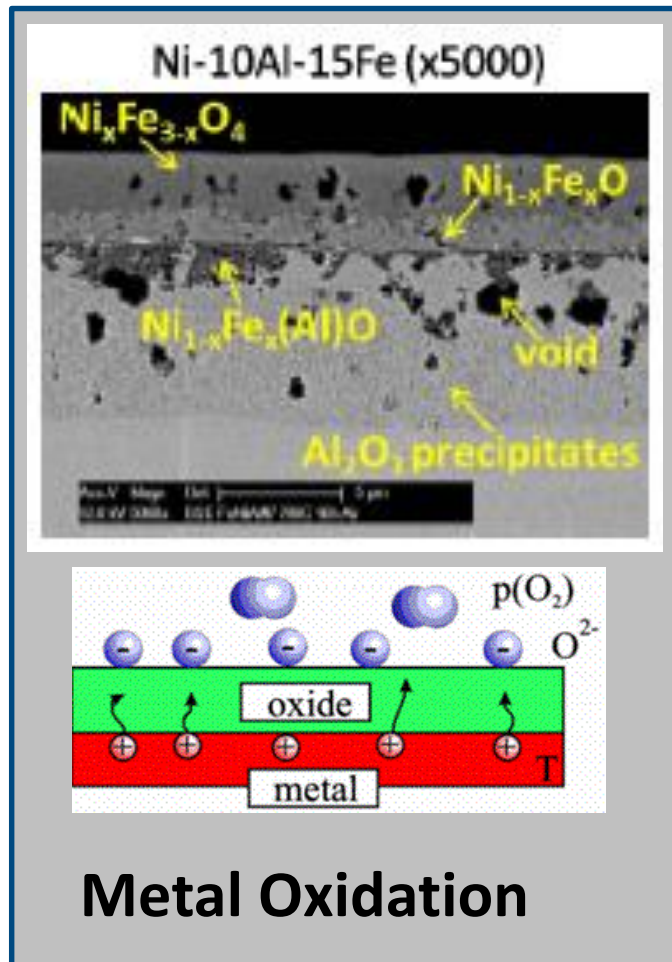


# Acknowledgements

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# Metal Oxidation Modeling Challenge



(Source: Internet)

Material's operating  
conditions

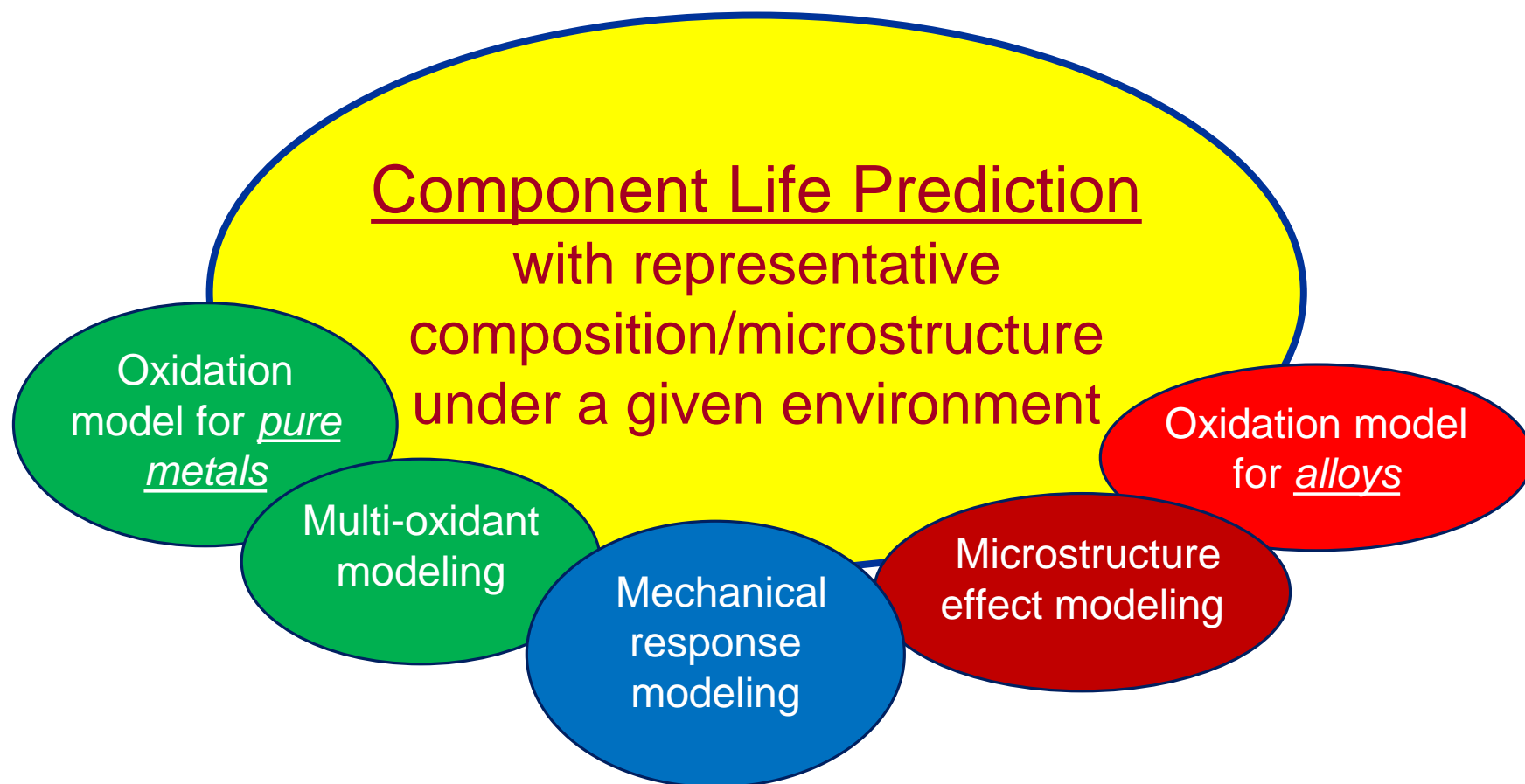


Modeling  
toolbox



Material Performance

# Modeling Toolbox

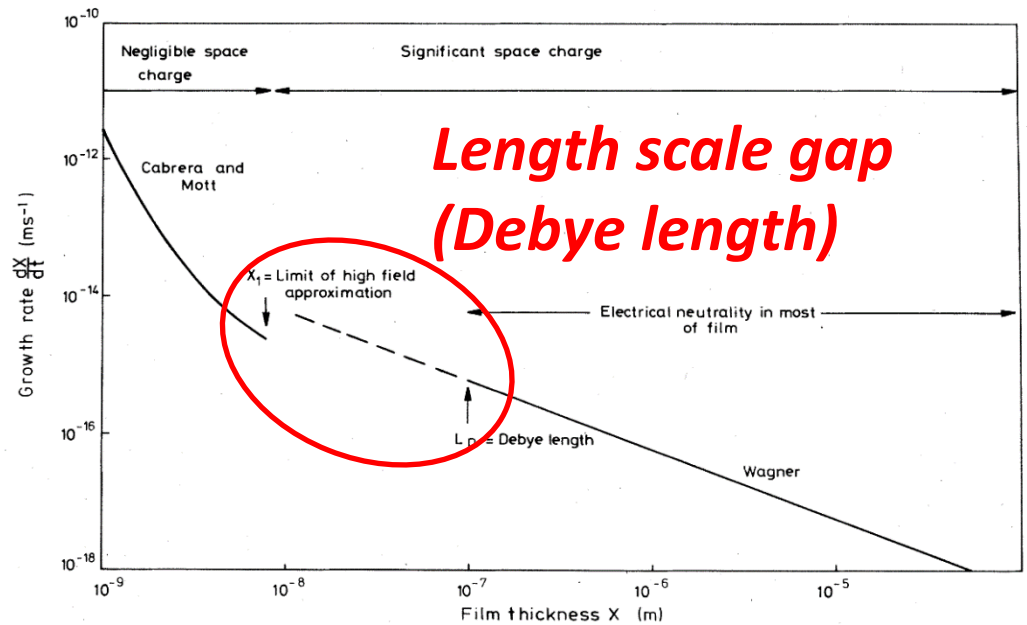


# State-of-the-art of Computational Modeling

Cabrera  
-Mott  
Theory

*Moderate  
film thickness*

Wagner  
Theory



(Atkinson, *Review of Modern Physics*, 1985)

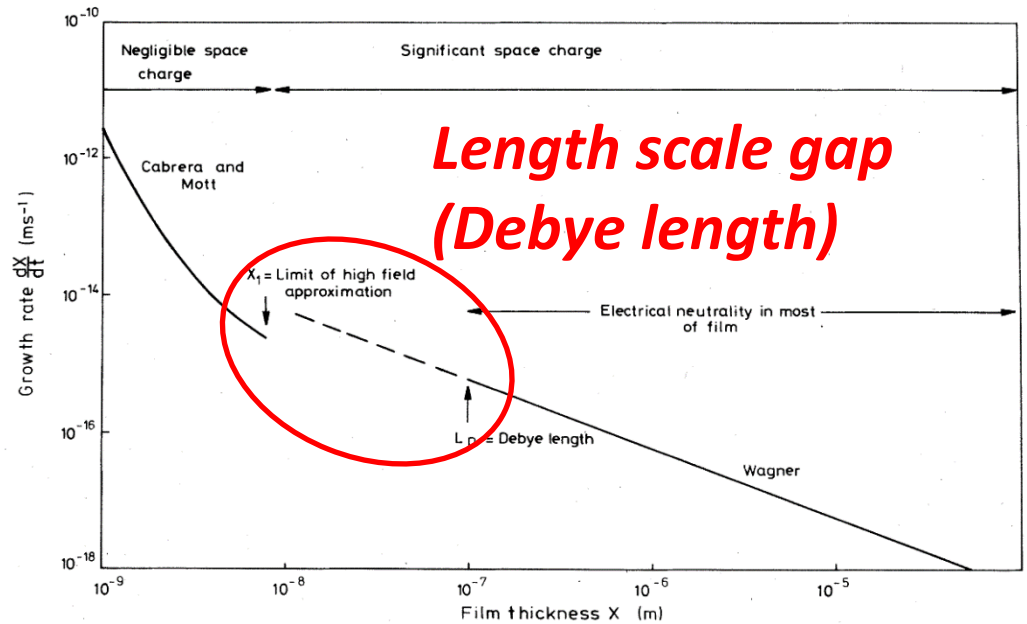
In this intermediate length regime, some common simplifications are not applicable such as local charge neutrality or constant electric field.

# Length Scale Gaps in Oxidation Theories

Cabrera  
-Mott  
Theory

**Moderate  
film thickness**

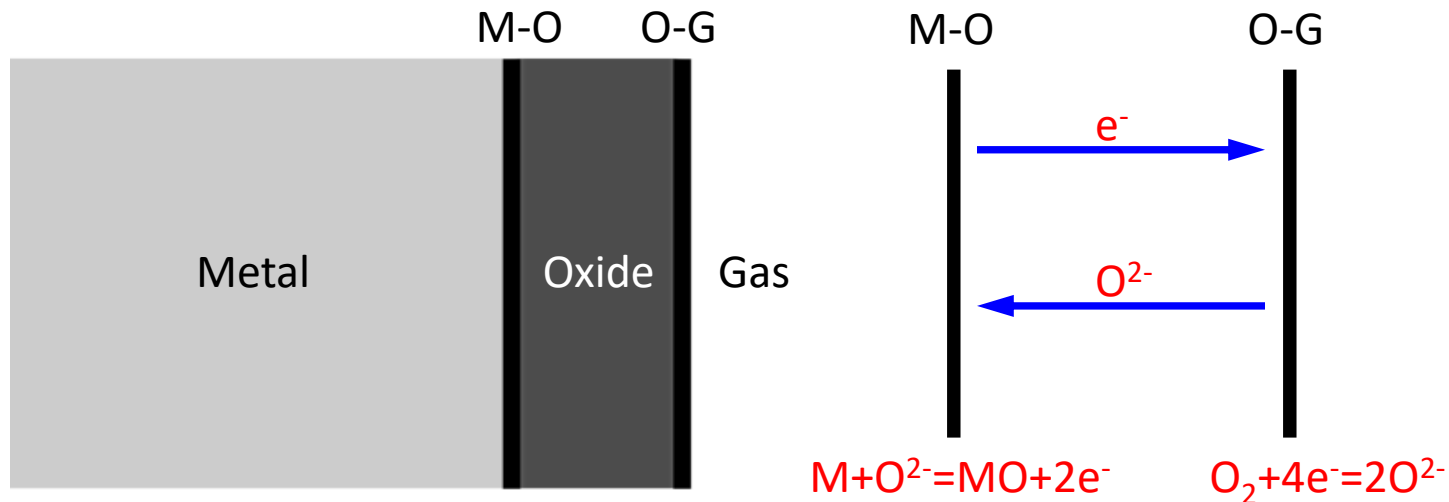
Wagner  
Theory



(Atkinson, *Review of Modern Physics*, 1985)

**Moderate film thickness regime:**  
*The coupling of charge interaction, ionic diffusion, and chemical reaction have to be addressed.*

# Oxidation Modeling in Pure Metals



Coupling  
physics with  
no viable  
simplification

- Chemical reaction
- Mass transport
- Charge interaction
- Evolving structure
- Evolving electric field

# Phase-field Method

## Governing Equations for Metal Oxidation

	Reaction	Diffusion + Electromigration
$[X^-]:$	$\frac{\partial c_1}{\partial t} = K_I \Lambda_\zeta (Q\tilde{c}_2 - \tilde{c}_1) - K_{II} \Lambda_\eta \tilde{c}_1$	$+ \nabla \cdot (\tilde{D}_1 \nabla \tilde{c}_1) - \frac{e}{k_B T} \nabla \cdot (D_1 c_1 z_1 \mathbf{E})$
$[e^-]:$	$\frac{\partial c_2}{\partial t} = K_I \Lambda_\zeta (Q\tilde{c}_2 - \tilde{c}_1) + K_{II} \Lambda_\eta \tilde{c}_1$	$+ \nabla \cdot (\tilde{D}_2 \nabla \tilde{c}_2) - \frac{e}{k_B T} \nabla \cdot (D_2 c_2 z_2 \mathbf{E})$
$[c^+]:$	$\frac{\partial c_3}{\partial t} =$	$\nabla \cdot (D_3 \nabla c_3) - \frac{e}{k_B T} \nabla \cdot (D_3 c_3 z_3 \mathbf{E})$
$[M]:$	$\frac{\partial \eta}{\partial t} = -K_V K_{II} \Lambda_\eta \tilde{c}_1$	$+ M_\eta \nabla^2 (\partial f / \partial \eta - \beta \nabla^2 \eta)$

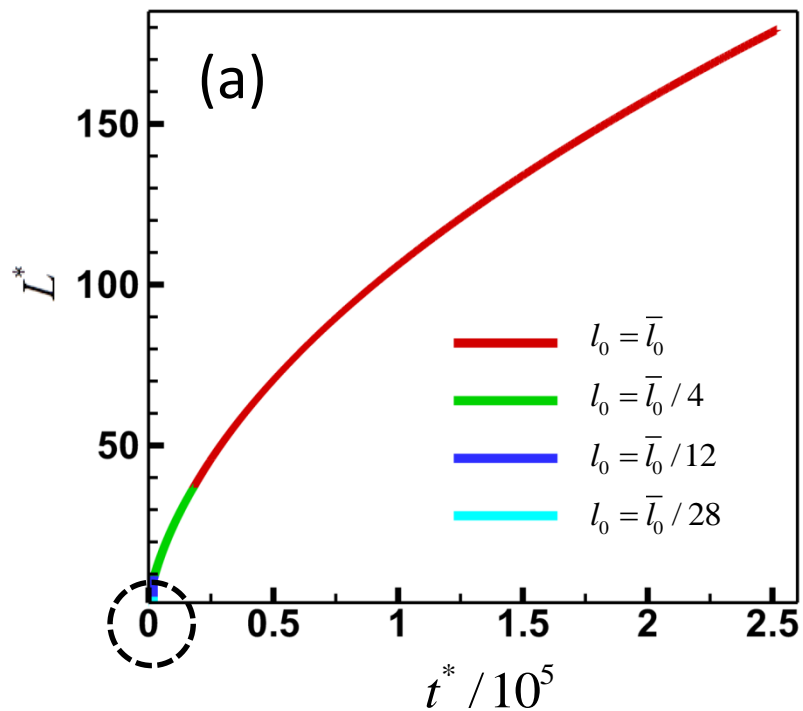
The electric field, satisfying Poisson's equation, is solved by an efficient numerical scheme for arbitrary dielectric heterogeneity

$$\nabla \cdot [\varepsilon(\mathbf{r}) \nabla \varphi(\mathbf{r})] + \rho_f(\mathbf{r}) = 0$$

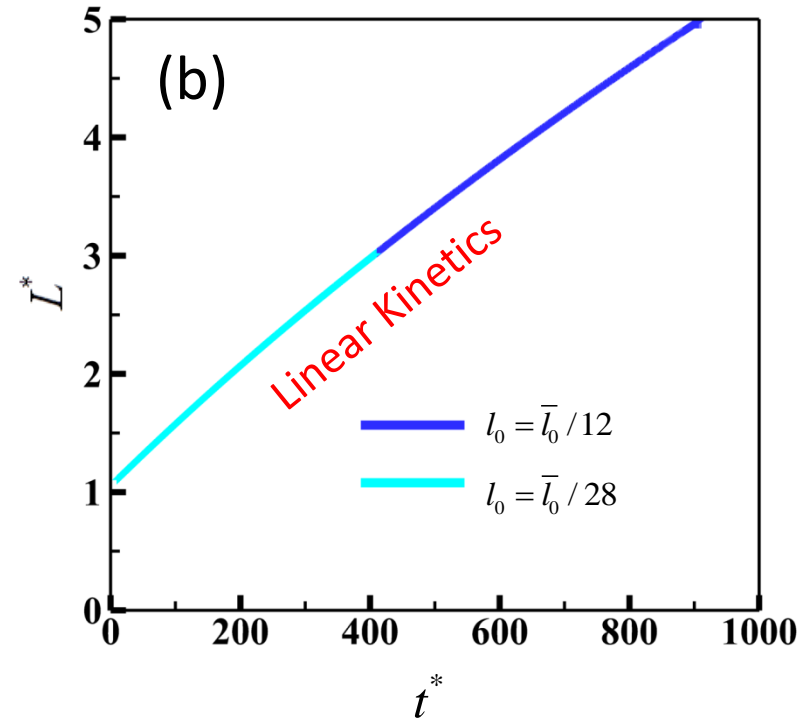


# Simulated Results on Oxidation Kinetics Modeling

## Linear → Parabolic kinetics Transition



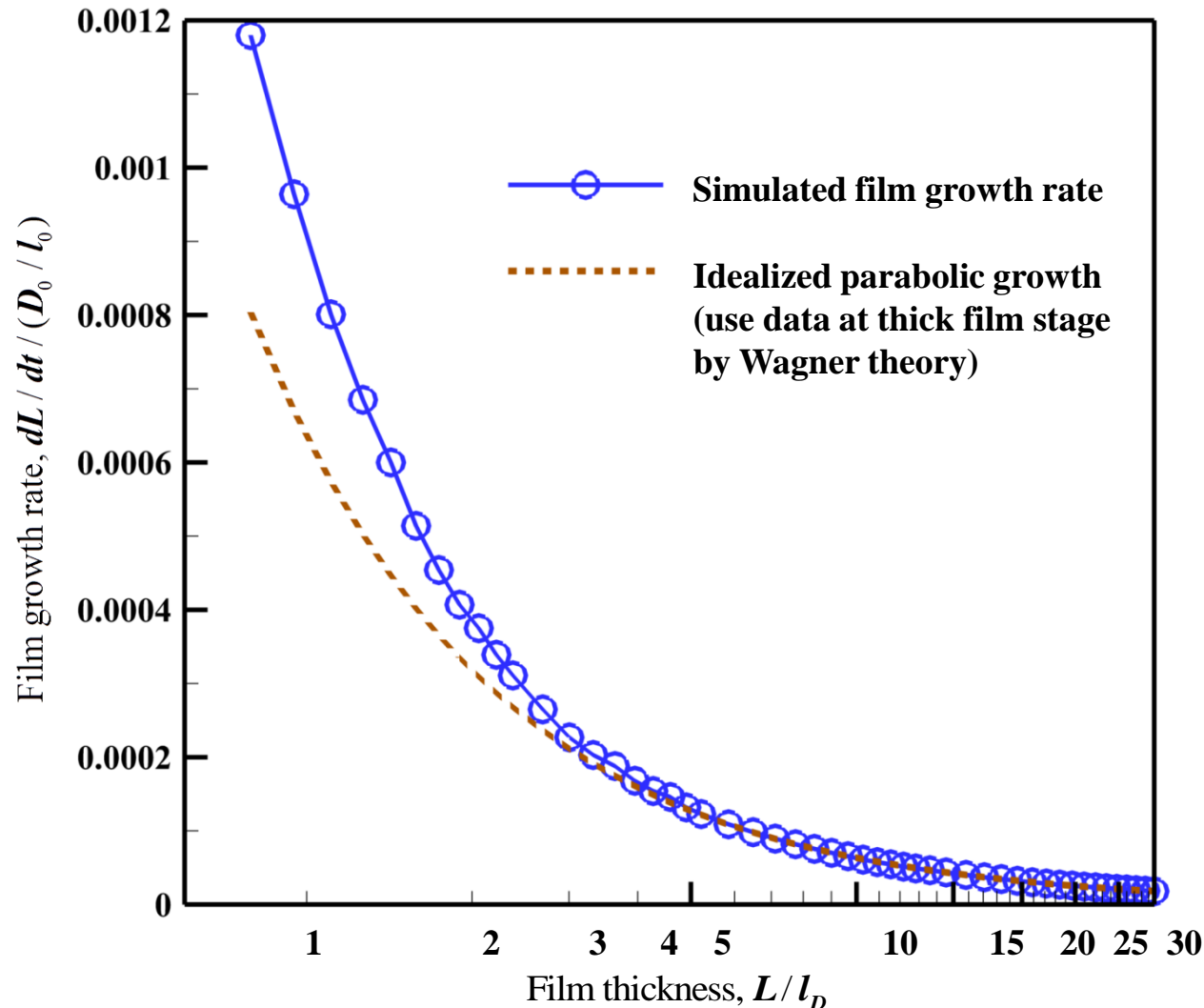
Overall growth kinetics



Initial stage growth kinetics

T Cheng, Y Wen and J Hawk, J. Phys. Chem. C 118(2014), 1269-1284

# Oxide Growth Rate vs. Film Thickness

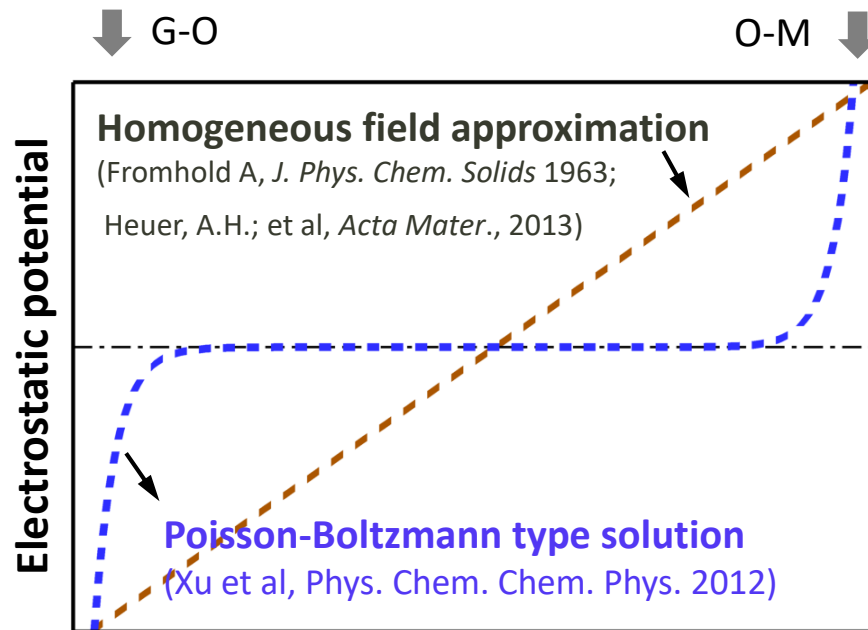


**Space charge effect can not be ignored**

# Results on Electric Field in a Growing Oxide Film

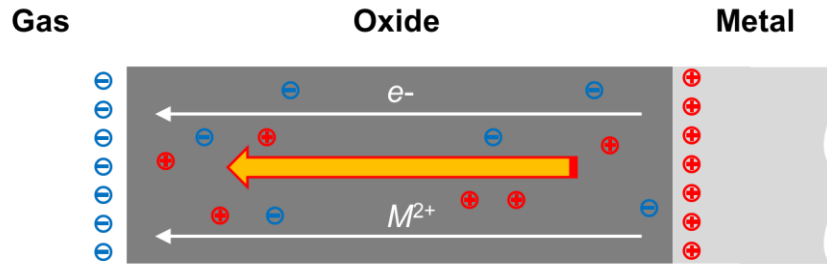
Two dominant representations:

- Homogeneous electric field across the film
- Electric field decays to zero exponentially away from the surface or interface

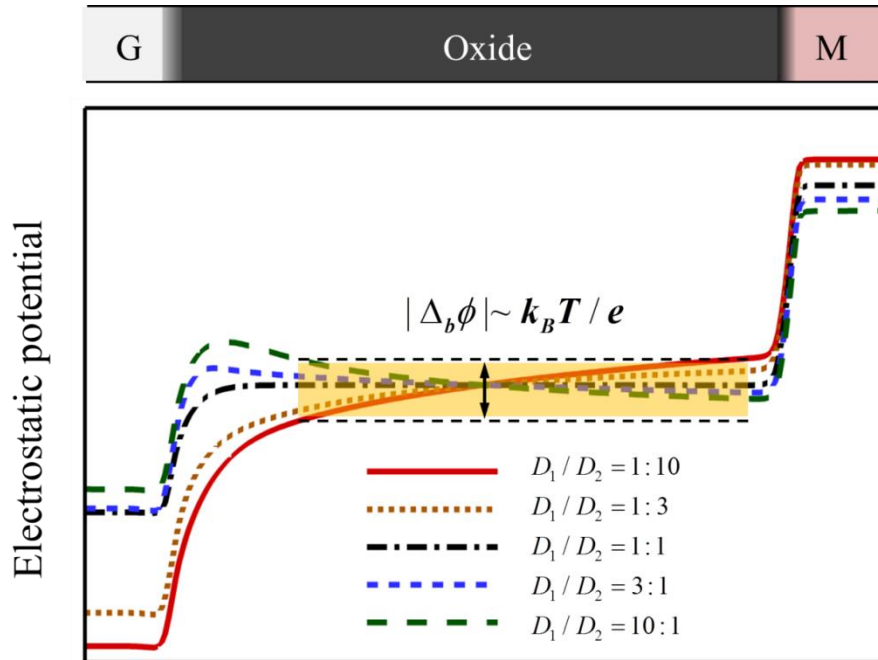


**Kinetics is missing!**

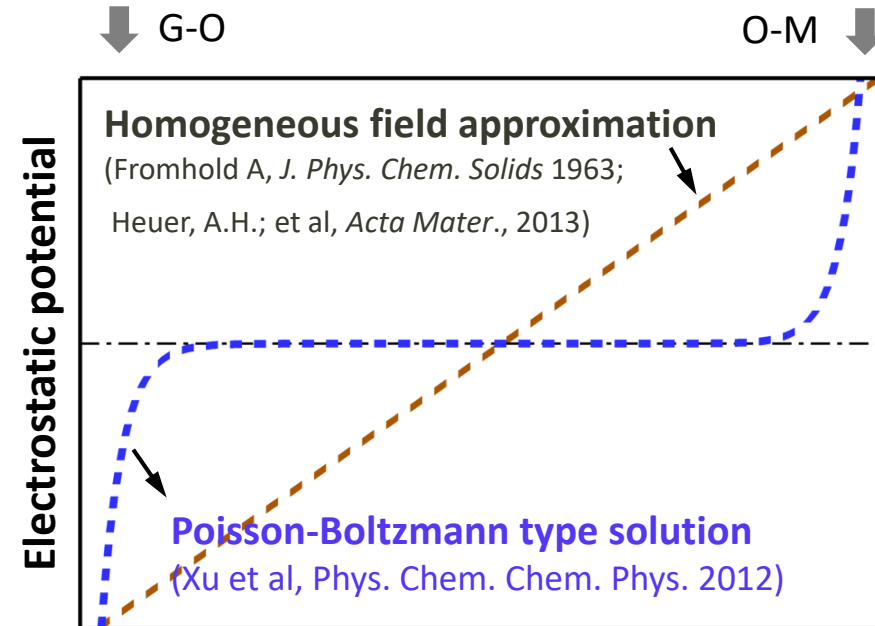
# Electric Field in a Growing Oxide Film



**Outward diffusion of metal ions and electrons with different valences**



**Simulated electrostatic potential profiles with different defect mobility ratios.**



**T Cheng, Y Wen, J. Phys. Chem. Lett. 5 (2014), 2289-2294**

# On-going Effort: Internal → External Oxidation

## Significance and Overview

Fe-, Ni-, or Co-base structural alloys applied at high temperatures invariably rely on formation of an externally oxidized, slowly growing layer (mainly  $\text{Al}_2\text{O}_3$  or  $\text{Cr}_2\text{O}_3$ ), for oxidation protection. Consequently, the transition from internal to external oxidation is a basis for design of those alloys.

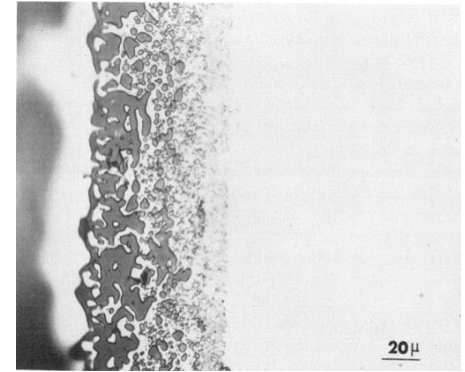


Fig. 1 Transition from internal to external oxidation in Co-8.99%Ti at 900°C for 528h, (G.H. Meier et al, 1976)

## Outstanding challenges to model this with Phase-Field:

### a) Modeling plasticity due to volume expansion with oxidation

1. Guo, X. H.; Shi, S. Q.; Ma, X. Q, Appl. Phys. Lett. 2005, 87;
2. Yamanaka, A.; Takaki, T.; Tomita, Y., Mater. Sci. Eng. A-Struct. Mater. Prop. Microstruct. Process. 2008, 491, 378.

- Elastic-perfect plasticity – No hardening behavior
- Deviatoric stress-free strain only – No dilatational deformation



# On-going Effort: Internal → External Oxidation

## Significance and Overview

Fe-, Ni-, or Co-base structural alloys applied at high temperatures invariably rely on formation of an externally oxidized, slowly growing layer (mainly  $\text{Al}_2\text{O}_3$  or  $\text{Cr}_2\text{O}_3$ ), for oxidation protection. Consequently, the transition from internal to external oxidation is a basis for design of those alloys.

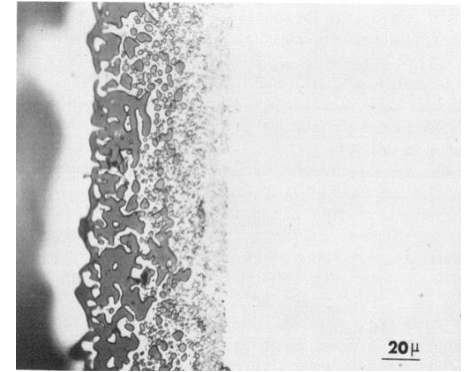


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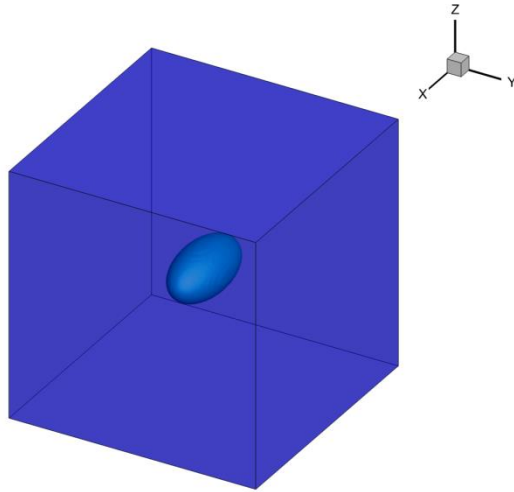
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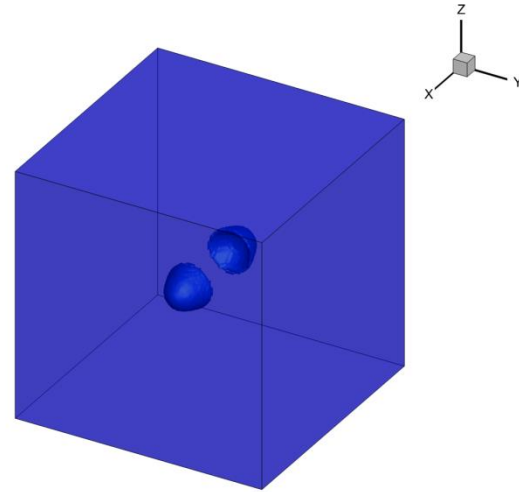
1. Guo, X. H.; Shi, S. Q.; Ma, X. Q, Appl. Phys. Lett. 2005, 87;
2. Yamanaka, A.; Takaki, T.; Tomita, Y., Mater. Sci. Eng. A-Struct. Mater. Prop. Microstruct. Process. 2008, 491, 378.

### b) Modeling coherency loss involving transition between coherent, semicoherent, and incoherent interfaces

# 3D Phase-field Elasto-Plasticity Simulation Demo



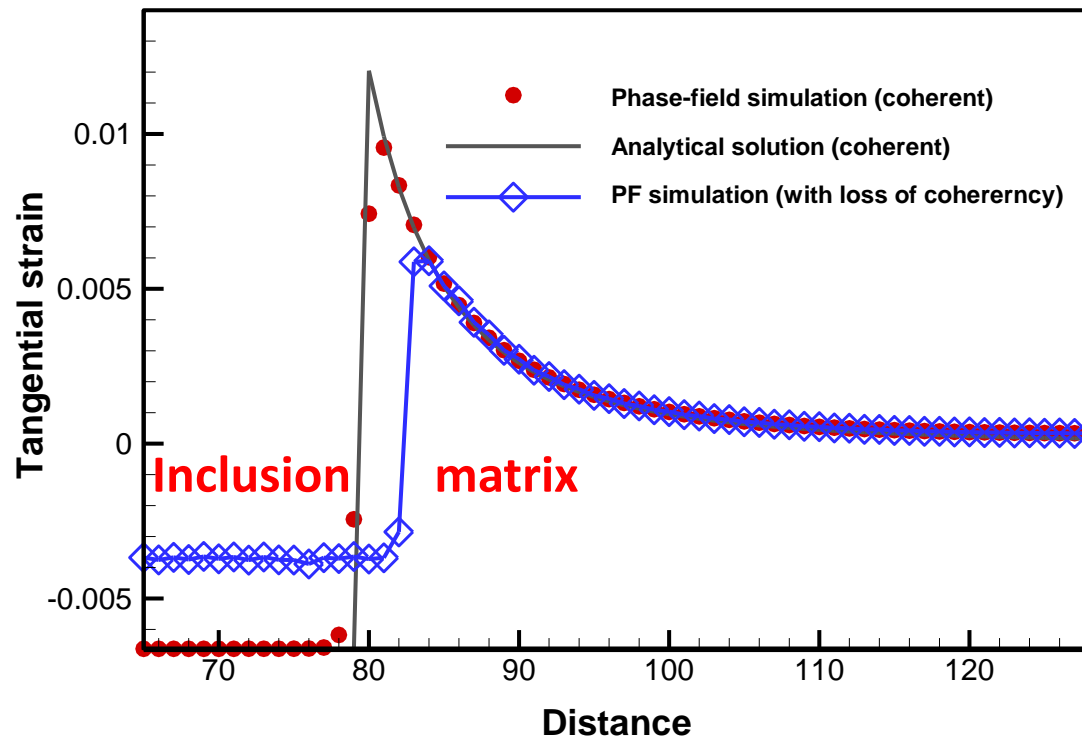
Ellipsoidal inclusion undergoes  
5% elongation along x-axis



Plastic deformation zone in the matrix

# Interface Coherency Effect on Elastic Energy

## A 3-D Simulation Demo



**Even for a dilatational inclusion, coherency loss can appreciably reduce elastic energy.**

Tangential strain for a spherical inclusion with isotropic eigenstrain of 2% volume change



# Summary

- Developed a *simulation capability* based on Phase-Field Method to simulate oxidation in simple systems – Oxidation kinetics and electric field
- *Further development* of the model is on-going to advance this model into a useful tool that can be used to eventually predict the life of an alloy

# Electric Field in a Growing Oxide Film

Two dominant representations:

- Homogeneous electric field across the film
- Electric field decays to zero exponentially away from the surface/interface assuming thermodynamic equilibrium

$$J_i = -D_i \nabla c_i + \varpi_i \mathbf{E} c_i \quad \text{Flux equations}$$

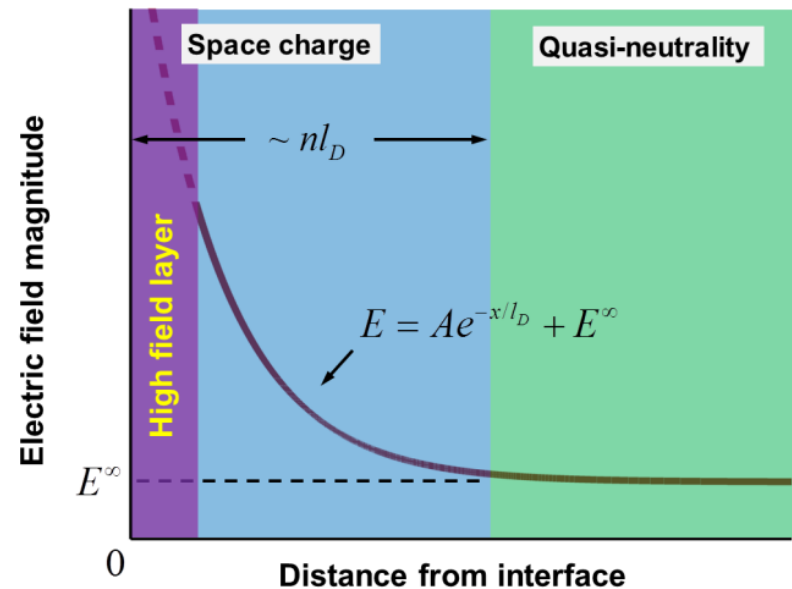
$$\varepsilon \nabla \cdot \mathbf{E} = \sum_i z_i e N_A c_i \quad \text{Linearized Poisson Boltzmann}$$

- Two negatively charged transporting species with identical valences: i.e.  $z_1=z_2=-1$  for electrons and interstitial anions
- Assume coupled-current condition

$$E = A e^{-x/l_D} + E^o$$

$$E^o = \frac{k_B T}{e \bar{c}} \frac{D_1 - D_2}{D_1 D_2} J^o$$

$$l_D = \sqrt{\varepsilon k_B T / N_A e^2 \bar{c}}$$



Schematic of the electric field near an interface with a decaying screening term plus a permanent remnant term .